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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/707,824	01/15/2004	Long-Hui Lin	LKSP0029USA	1823	
27765	7590 10/24/2005		EXAM	INER	
NORTH AM	ERICA INTELLECT	COLEMAN, WILLIAM D			
P.O. BOX 506 MERRIFIELD		ART UNIT	PAPER NUMBER		
MEKKITIEE	), VA 22110		2823		
			DATE MAILED: 10/24/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

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	A	pplication No.	Applicant(s)	7,7,0
	i	0/707,824	LIN, LONG-HUI	
Office Action Summary		xaminer	Art Unit	
		/. David Coleman	2823	
The MAILING DATE of th Period for Reply	is communication appear	rs on the cover sheet w	ith the correspondence ac	ddress
A SHORTENED STATUTORY WHICHEVER IS LONGER, FROM Extensions of time may be available under after SIX (6) MONTHS from the mailing da If NO period for reply is specified above, the Failure to reply within the set or extended Any reply received by the Office later than earned patent term adjustment. See 37 C	OM THE MAILING DATE the provisions of 37 CFR 1.136(a) the of this communication. the maximum statutory period will a period for reply will, by statute, cau three months after the mailing dat	E OF THIS COMMUNI  ). In no event, however, may a  pply and will expire SIX (6) MOI  se the application to become Al	CATION. reply be timely filed NTHS from the mailing date of this of BANDONED (35 U.S.C. § 133).	
Status				
1) Responsive to communic	ation(s) filed on 12 Auau	ıst 2005.		
2a)⊠ This action is <b>FINAL</b> .		tion is non-final.		
3) Since this application is in closed in accordance with	condition for allowance	except for formal mat		e merits is
Disposition of Claims				
4) ☐ Claim(s) <u>1-9</u> is/are pendir 4a) Of the above claim(s) 5) ☐ Claim(s) is/are allowable 6) ☐ Claim(s) <u>1-9</u> is/are rejected 7) ☐ Claim(s) is/are objected 8) ☐ Claim(s) are subjected	is/are withdrawn wed. ed. ected to.			
Application Papers				
9)☐ The specification is object	ed to by the Examiner.			
10)☐ The drawing(s) filed on	is/are: a)□ accept	ed or b) Dobjected to	by the Examiner.	
Applicant may not request th	• •	• • • • • • • • • • • • • • • • • • • •		
Replacement drawing sheet 11) The oath or declaration is	· ·	·	• • •	
Priority under 35 U.S.C. § 119	•			
12) Acknowledgment is made  a) All b) Some * c)  1. Certified copies of  2. Certified copies of  3. Copies of the certified	None of: the priority documents hathe priority documents hathe the priority documents hathe tied copies of the priority the International Bureau (F	ave been received. ave been received in A documents have beer PCT Rule 17.2(a)).	Application No  received in this National	Stage
Attachmont/s)				
Attachment(s)  1)  Notice of References Cited (PTO-892)	١	4) Interview	Summary (PTO-413)	
Notice of References Cited (F10-092     Notice of Draftsperson's Patent Draw     Information Disclosure Statement(s) (     Paper No(s)/Mail Date	ing Review (PTO-948)	Paper No	s)/Mail Date Informal Patent Application (PT	O-152)

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### **DETAILED ACTION**

## Response to Arguments

1. Applicant's arguments filed August 12, 2005 have been fully considered but they are not persuasive.

2. In response to applicant's argument that the references fail to show certain features of applicant's invention, it is noted that the features upon which applicant relies (i.e., second defect inspection (defect review) are not recited in the rejected claim(s). Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims. See *In re Van Geuns*, 988 F.2d 1181, 26 USPQ2d 1057 (Fed. Cir. 1993).

# Claim Rejections - 35 USC § 102

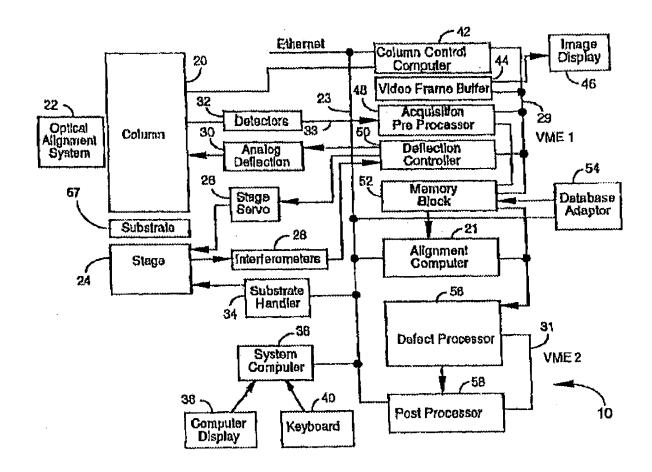
1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1-9 are rejected under 35 U.S.C. 102(b) as being anticipated by Satya et al., U.S. Patent 6,445,199 B1.

Satya discloses a semiconductor process as claimed. See FIGS. 1-35, where Satya teaches the following limitations.

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3. Pertaining to claim 1, <u>Satya</u> teaches a method of defect review comprising following steps:

providing a wafer with a plurality of defects;

performing a defect inspection to detect the defects; performing an automatic defect classification according to a database to separate the defects into a plurality of defect types; and performing a defect review;

wherein each defect type has different sampling ratios in the defect review according to its influence degree of process yield (see column 7, lines 14-48).

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4. Pertaining to claim 2, <u>Satya</u> teaches the method of claim 1 wherein the database comprises information about the plurality of defect types and defect information corresponding to each defect type (see FIG. 3).

- 5. Pertaining to claim 3, Satya teaches the method of claim 2 wherein the defect information comprises the influence degree of the process yield of each defect type.
- 6. Pertaining to claim 4, <u>Satya</u> teaches the method of claim 3 wherein the database separates the defect types into killer defects and non-killer defects according to the influence degree of the process yield (column 31, lines 3-14).
- 7. Pertaining to claim 5, <u>Satya</u> teaches the method of claim 4 wherein the sampling ratio of the killer defects in the defect review is larger than that of the non-killer defects (column 31, lines 25-51).
- 8. Pertaining to claim 6, <u>Satya</u> teaches the method of claim 3 wherein the database separates the defects into pre-layer defects and adding defects, and further separates the adding defects into killer defects and non-killer defects (see column 31).
- 9. Pertaining to claim 7, <u>Satya</u> teaches the method of claim 6 wherein the defect review focuses on the adding defects.

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10. Pertaining to claim 8. <u>Satya</u> teaches the method of claim 1 wherein after finishing the defect inspection, a judgment of cluster defects is performed and a defect review with a high sampling ratio is performed on the cluster defects if the cluster defects exist.

11. Pertaining to claim 9, <u>Satya</u> teaches the method of claim 1 wherein the database is updated according to the result of the defect review after finishing the defect review.

### Conclusion

- 12. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).
- 13. A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.
- 14. Any inquiry concerning this communication or earlier communications from the examiner should be directed to W. David Coleman whose telephone number is 571-272-1856. The examiner can normally be reached on Monday-Friday 9:00 AM 5:30 PM.

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15. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

16. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

W. David Coleman Primary Examiner Art Unit 2823

WDC

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